

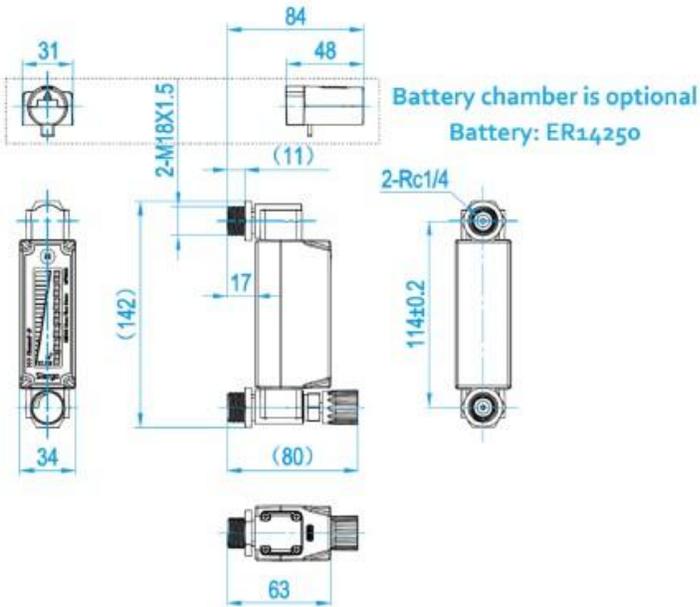


MEMS mass flow controllers With *Thermal-D* sensing technology

MF660 Series

MF660 series mass flow controllers are manufactured with Siargo's *Thermal-D* mass flow sensing technology. With battery power options, the products offer programmable manual mass flow control. The series can readily replace rotameters with a similar footprint and cost scheme while providing unprecedented performance that changes the landscape of process monitoring and control.

Dimensions



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Specifications

Range	1,2,5,10,20,50, 70	SLPM
Accuracy	±2.0	%FS
Turn-down	30:1	
Pressure range	0~1.0	MPa
Operating temperature	-10~+55	°C
Output	I ² C / RS485 Modbus/ LCD	
Humidity	<95, no condensation	%RH
Power	3.6~24 Vdc or ER1425 lithium-ion battery	
MENU access	1 function keyboard, front	
Electrical interface	USB Type-C	
Display	Instant flowrate, accumulated or totalized flowrate	
Protection	IP40	
Calibration	Air @ 0°C, 101.325 kPa	
CE	EN61000-2; -3; -4	

Product selection

